

<b>Search Notes</b> 	<b>Application/Control No.</b>	<b>Applicant(s)/Patent under Reexamination</b>
	10/751,477	YOU, DONG JAE
	<b>Examiner</b> Wen-Ying P. Chen	<b>Art Unit</b> 2871

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner